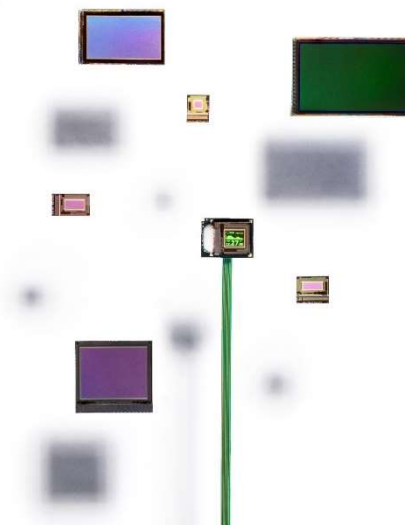
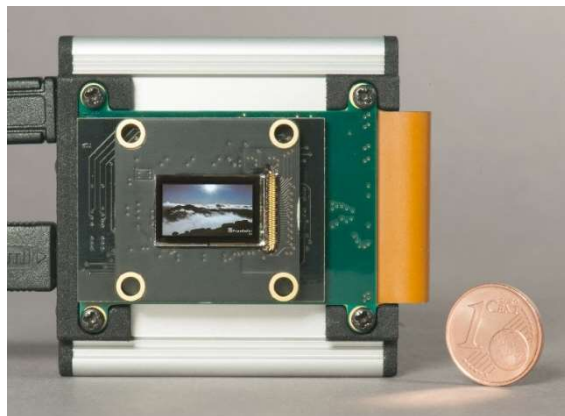
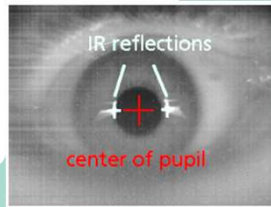

„O/LED-on-silicon for near-to-eye microdisplays and sensing “

Fraunhofer Institute for Organic Electronics, Electron Beam and Plasma Technology FEP
Dresden, D-01109, Germany

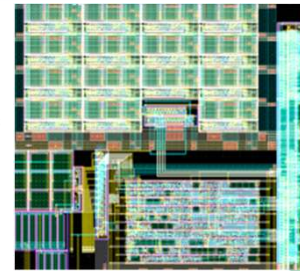


Our Focus: Device Development, Prototyping and Manufacturing

Software development,
e.g. eye-tracking

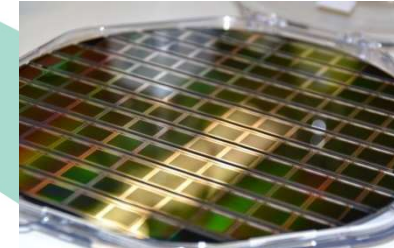


Technical
Consulting

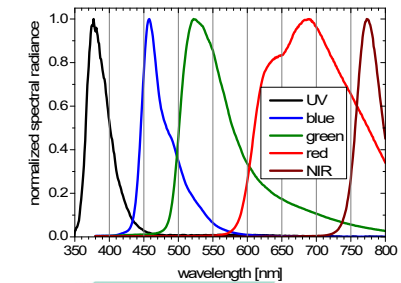


IC Design

Foundry relation,
CMOS backend



OLED/OPD Design



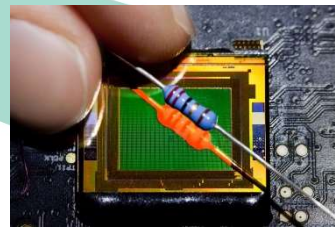
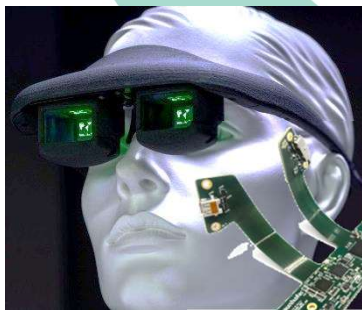
Electronics and
system design



X-on-Silicon post-
processing (8")

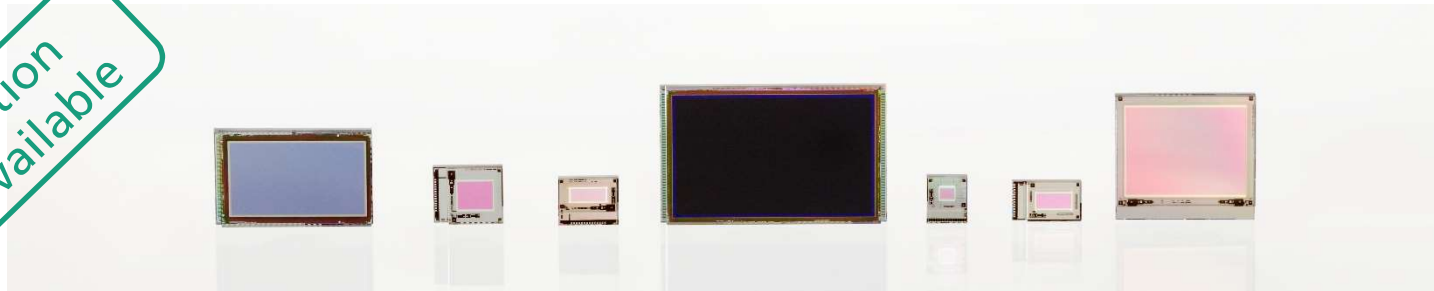


Electro-optical Test



Characteristics of microdisplay designs

Evaluation Kits available



Ultra-low power

Bi-directional

AR

VR

	UUGL1120	UUGL1220	UUGL1320	EBCW1020	HUCW1010	JUCW1010
resolution	304x256	304x128	720x256	800x600	1280x720	1920x1200
color	mono	mono	mono	RGBW	RGBW	RGBW
Max. current per pixel	~2μA/pixel (~1,3A/cm ²)	~2μA/pixel (~1,3A/cm ²)	~900nA/pixel (~3,6A/cm ²)	~1μA/pixel (~1,56A/cm ²)	~2.8μA/pixel (~2,3A/cm ²)	~2.8μA/pixel (~2,3A/cm ²)
Screen diagonal	0.19"	0.16"	0.15"	0.63"	0.64"	1.0"
Data Interface	SPI	SPI	SPI	parallel	parallel	parallel
Configuration interface	SPI	SPI	SPI	I2C	I2C	I2C
Typ. Power consumption	1-3mW	1-3mW	1-3mW	200mW@ 60Hz	100mW@ 60Hz	140mW@ 60Hz



Outlook: O/LED-on-Silicon features and applications

- high-brightness
 - AR see-through smart glasses
- smart *bi-directional* micro-displays
 - e.g. on-chip embedded eye-tracking
- high-resolution
 - more content (→ HD)
 - 3D, LF, holographic displays
 - smaller chip size, lower cost
- extended spectral emission and detection range
 - $\langle \rangle$ VIS
 - non-OLED sources → QD, μ LED
- New form factors
 - Curved surfaces
 - Non-square shapes
 - Irregular pixel arrays
 - Transparent backplanes
 - Integration into flexible substrates



Collaboration, contact

- Looking for **partners** in R&D and exploitation
 - Customer-/application-specific devices
 - Application requirements, specifications
 - AR, VR, imagers, sensors, lab-on-chip,...
 - System/application integration
 - optics, electronics, sensing, communication,...
 - Manufacturing technology
 - new materials/processes (e.g., μ LED, QD)
 - Pilot-fabrication
 - Privately and publicly funded collaborative projects
 - Technology transfer/licensing



■ Dr. Uwe Vogel

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